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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicant: Chih-Ning Wu Examiner: Umez Eronini, Lynette T
 Filing Date: 07/16/2001 Art Unit: 1765
 App. No.: 09/682,054 Docket No.: NAUP0374USA

10 Title: EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL
 DAMASCENE STRUCTURES

 To: Commissioners for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

15 Subject: Response to the Office action dated 03/14/2003

20 Dear Sir or Madame:

INTRODUCTORY COMMENTS

25 In response to the Office action identified above, the above-identified application is
to be amended as indicated in the following sections. Consideration of all amendments is
politely requested.

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